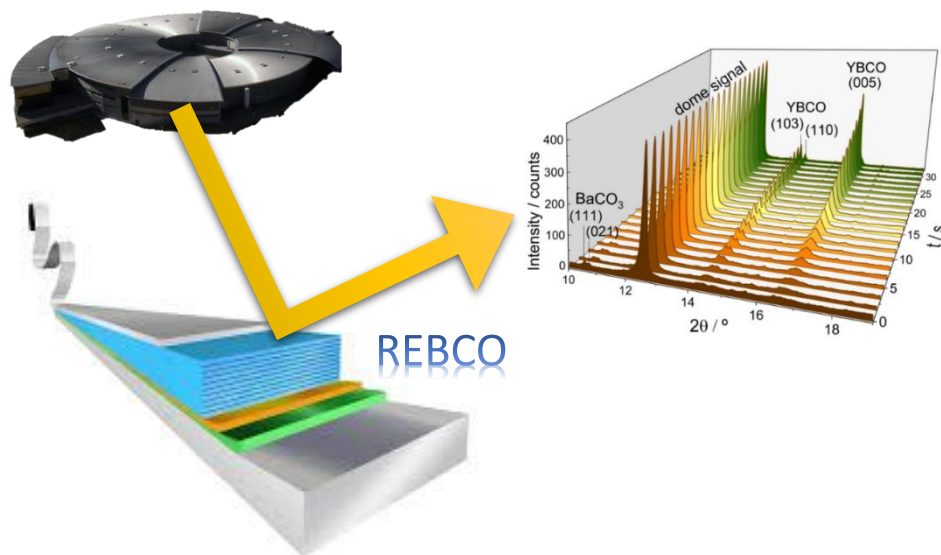


# In-situ X-Ray Diffraction revealing the reaction mechanism of ultrafast Transient Liquid Assisted Growth of superconducting thin films

**Elzbieta Pach**<sup>1</sup>

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GRMT, University of Girona<sup>2</sup>, Spain  
ALBA Synchrotron<sup>3</sup>, Cerdanyola del Valles, Spain  
SOLEIL Synchrotron<sup>4</sup>, Saint Aubin, France



**XI AUSE Conference**  
**VI ALBA Users Meeting**  
Oviedo  
2 – 6 September 2024

# Who are we and what do we do?

An interdisciplinary group of physicists, chemists, materials scientists and engineers committed to enable High Temperature Superconducting materials in our society.

Investigating fundamental understanding on Materials & Science of Superconductors to process scalability and integration in devices.



**Prof. Rosa Palacin, ICMAB**  
**BATTERIES + SUPERCONDUCTORS**



## NET-ZERO INDUSTRY ACT by European Commission

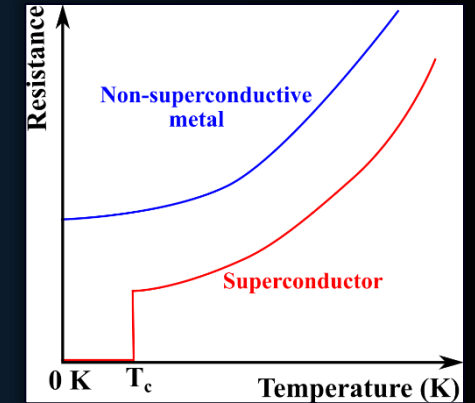
“Net-zero” CO<sub>2</sub> emissions by 2050

*Functional materials for energy applications*

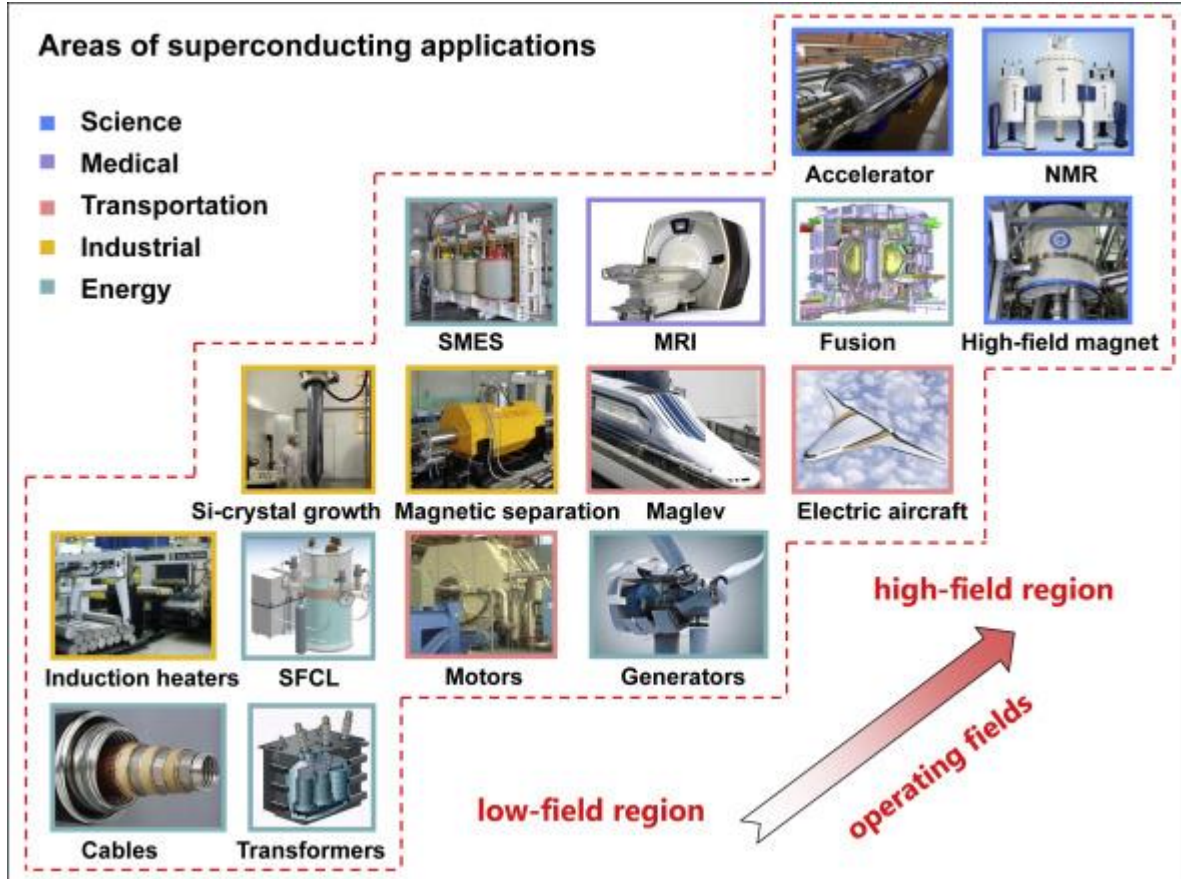
# Why do we do what we do?

## Superconducting Materials

- Lossless electrical transport
- Efficient energy transportation
- Enhance resilience of power grids
- New possibilities at high magnetic fields



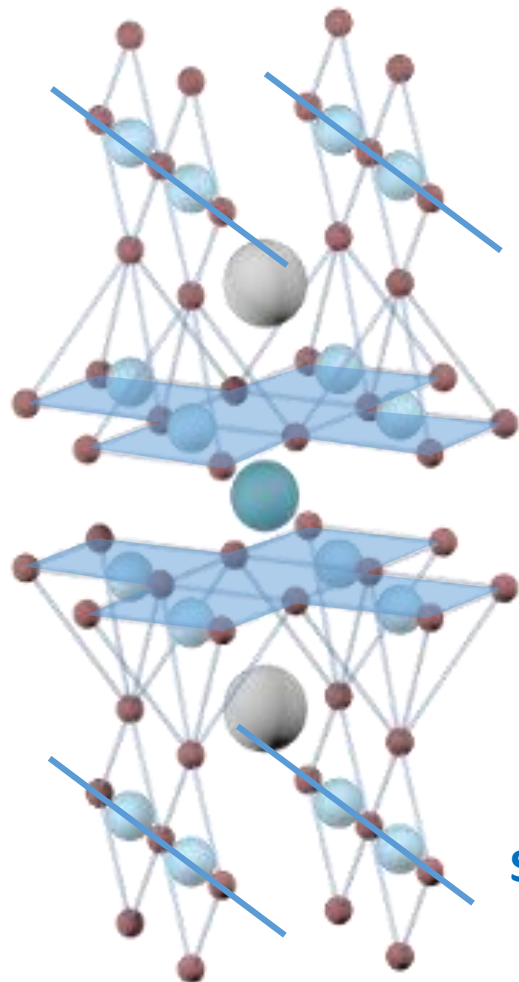
# The power of High Temperature Superconductors



iScience 2021, Volume 24, Issue 6, 102541, <https://doi.org/10.1016/j.isci.2021.102541>

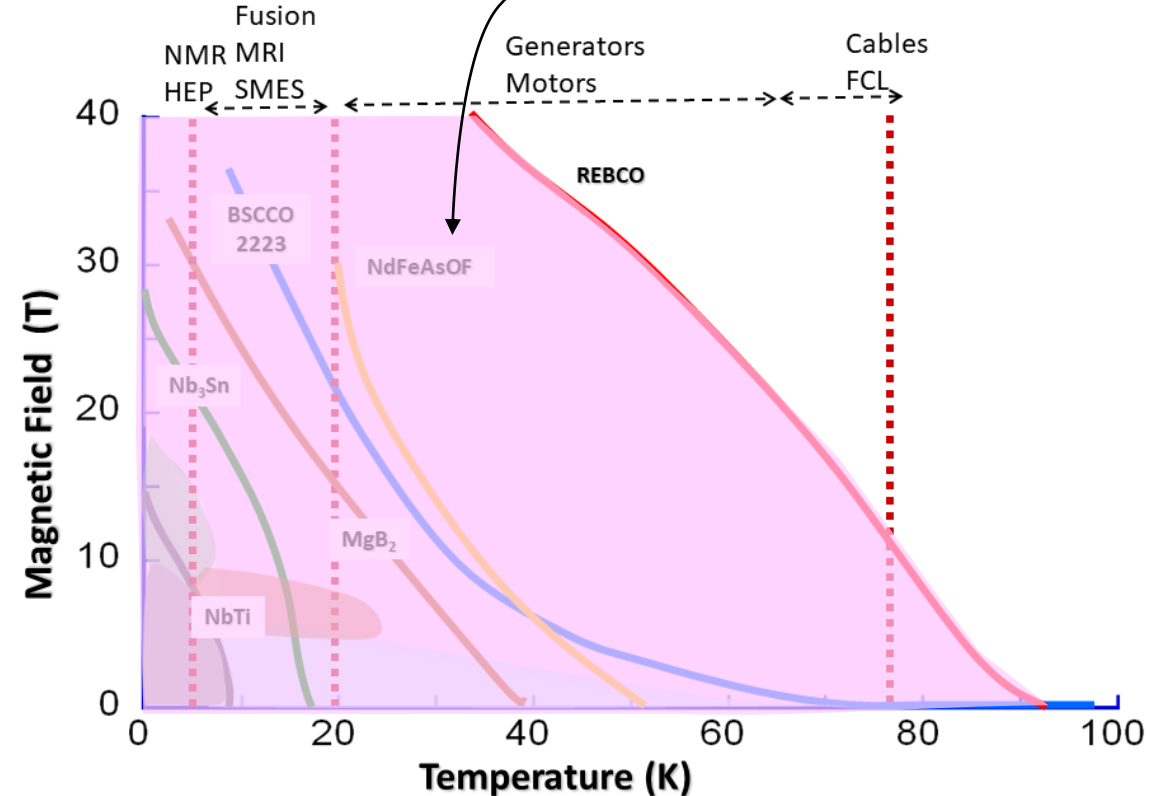
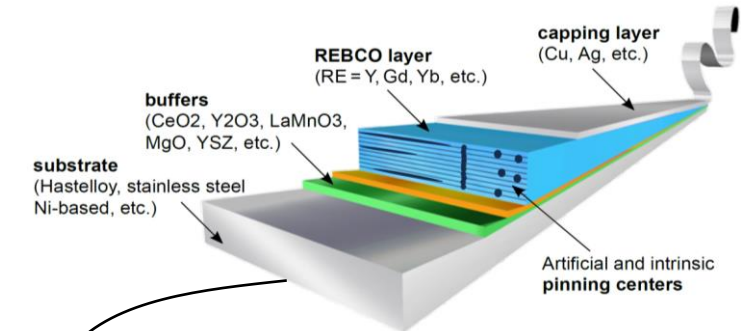


# REBCO = The highest field and highest temperature superconductor



Superconducting  $\text{CuO}_2$  planes

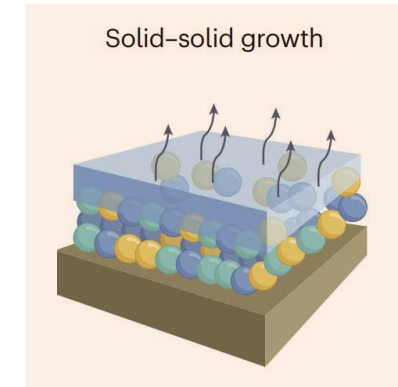
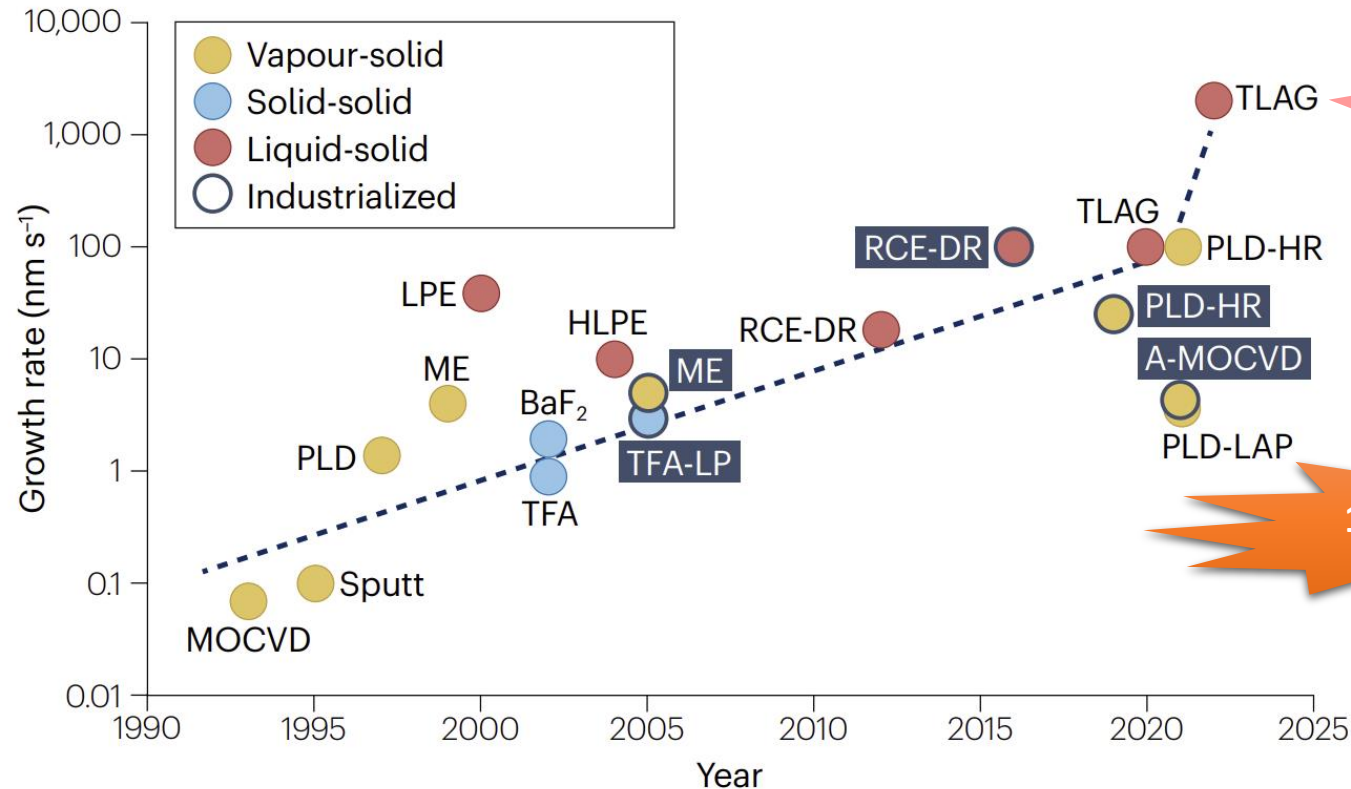
Superconducting Cu-O chains



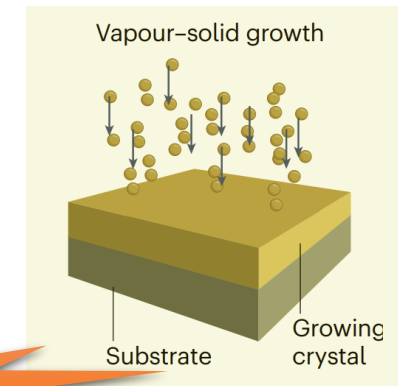
# Reaching high Growth Rates: A path towards cost reduction

↓ 
$$\frac{\text{Cost}}{\text{Performance}} = \frac{\text{total cost per year}}{G \times L \times W \times (I_{c-w}/d)} = \frac{\text{€}}{kA \times m}$$

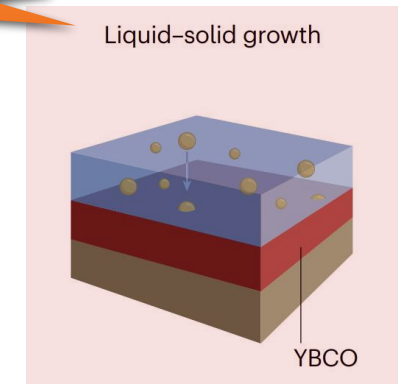
$G$  = growth rate  
 $W$  = tape width  
 $L$  = tape length  
 $d$  = tape thickness



$G = 0.5-5 \text{ nm/s}$



$G = 0.5-25 \text{ nm/s}$



$G = 10-1000 \text{ nm/s}$

# Transient Liquid Assisted Growth of REBCO films

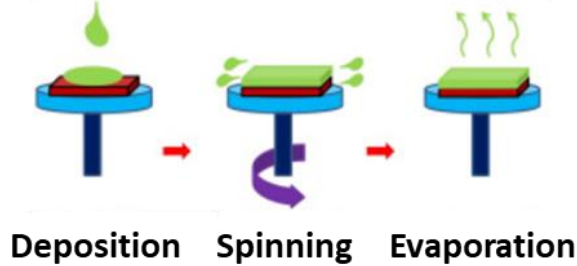
High-throughput, scalable and low cost production of Coated Conductors

Metal-organic inks

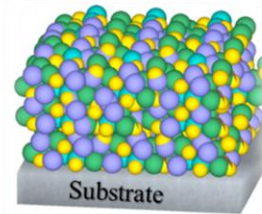


Deposition on substrate

Spin coating



Low Temperature pyrolysis



*TLAG process*  
Ultrafast kinetic growth

High temperature crystallization

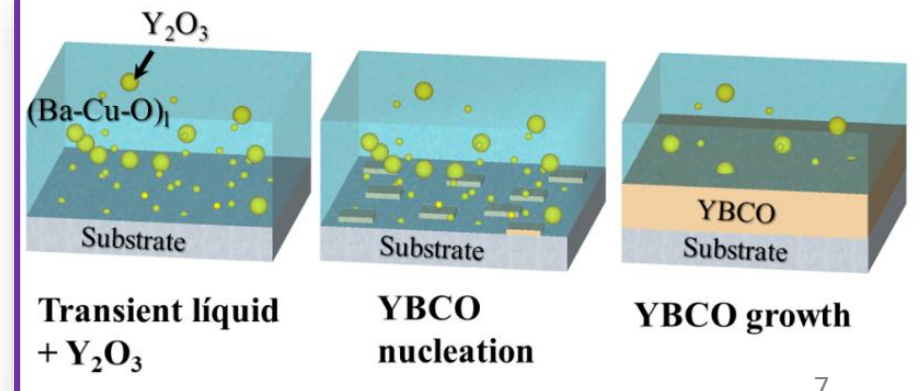
*Chemical solution deposition*

Need of advanced characterization for process understanding and optimization by in-situ growth at light sources:

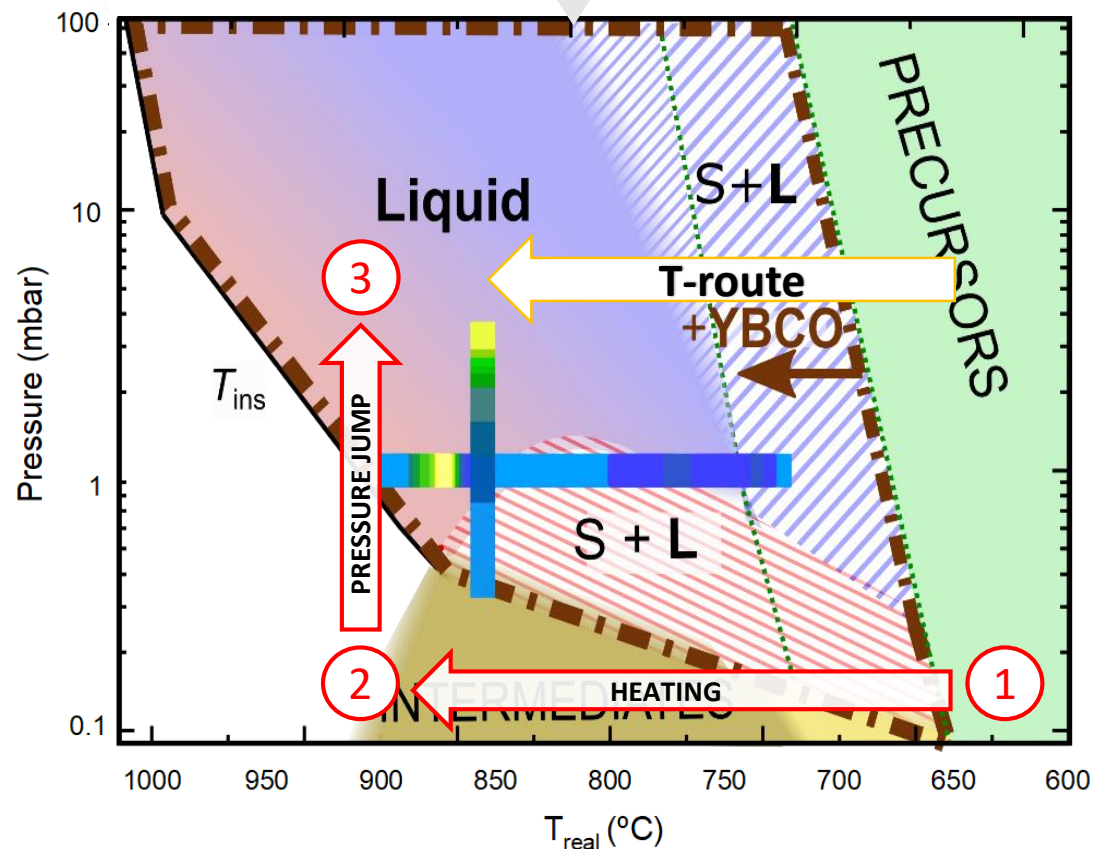
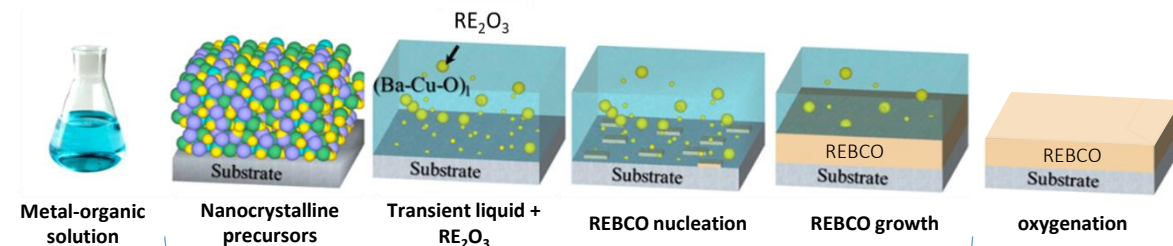
- X-ray diffraction (phase transformations and orientation)

Experiment conditions:

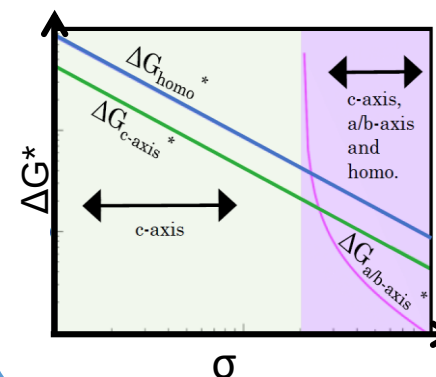
$P_T$ ,  $P_{O_2}$ , Temperature, heating and pressure ramp, gas velocity,...



# TLAG growth control and characterization



Control of TLAG process: supersaturation  $\sigma$



$\sigma \uparrow \Rightarrow \text{growth rate} \uparrow$

$\sigma \uparrow \Rightarrow \text{epitaxy} \downarrow$

Compromise between high growth rates and epitaxy

- ① Nanocrystalline precursors:  $\text{BaCO}_{3(s)} + \text{CuO}_{(s)} + \text{Y}_2\text{O}_{3(s)}$
- ① HEATING  $\rightarrow$  ② Intermediate reactions
- ② PRESSURE JUMP  $\rightarrow$  ③ Transient liquid formation:  $(\text{Ba} - \text{Cu}^{\text{I/II}} - \text{O})_{(\text{l})} + \text{Y}_2\text{O}_{3(s)}$
- ③ REBCO growth:  $\text{YBa}_2\text{Cu}_3\text{O}_{7-\delta}$

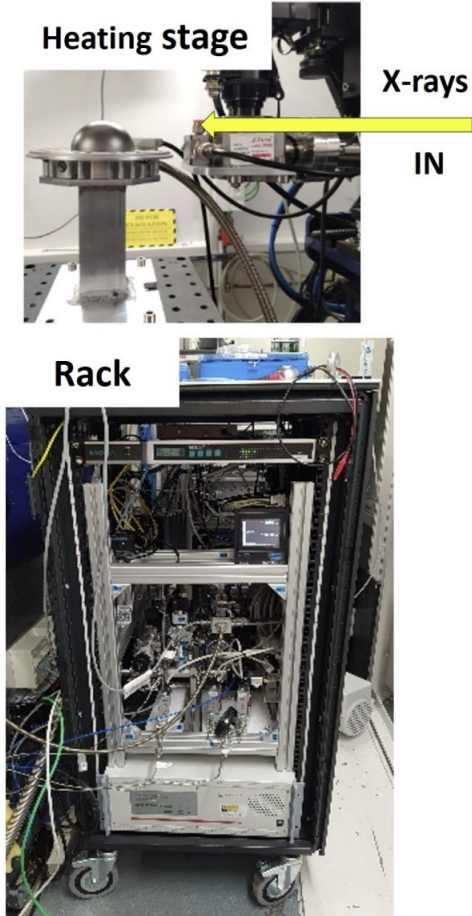
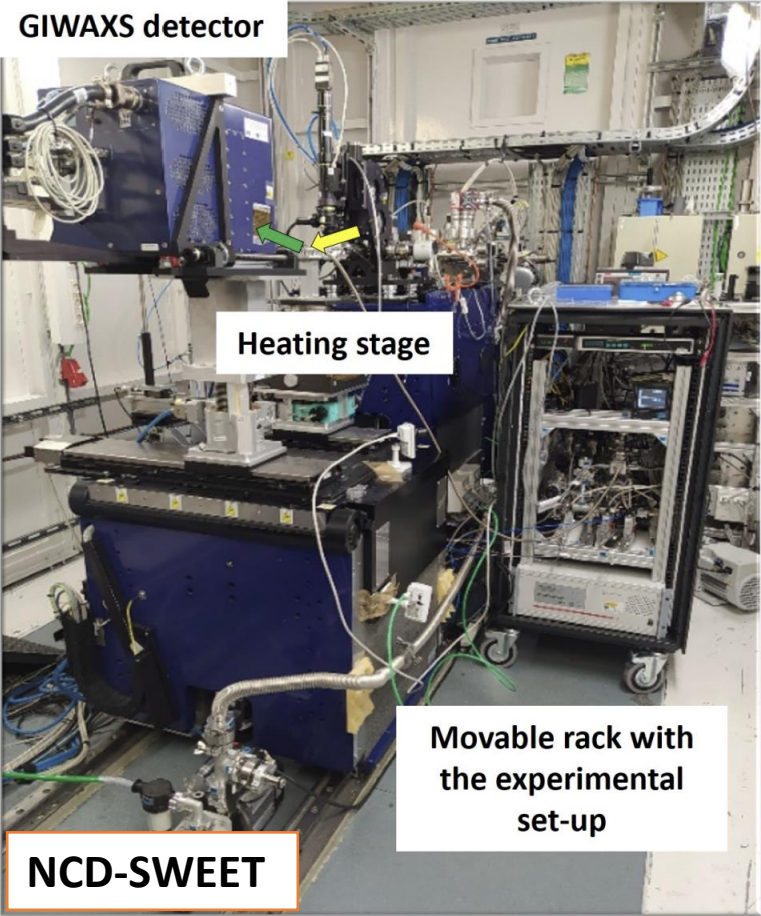
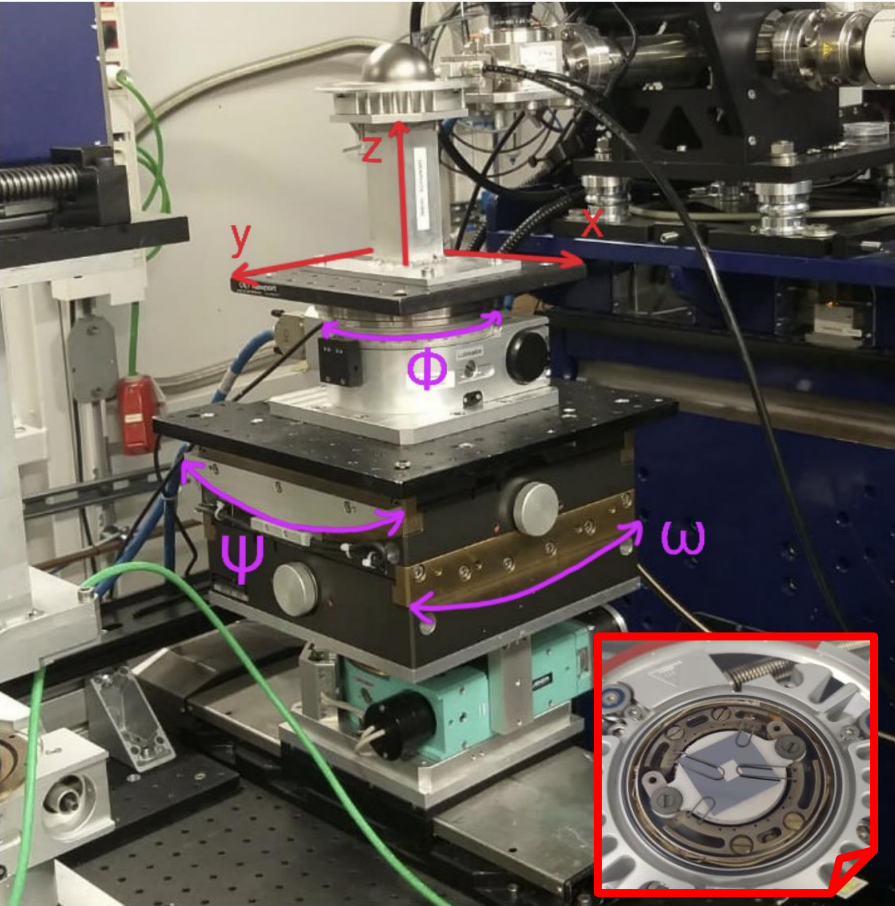


In-situ XRD at ALBA Synchrotron enables studying intermediate phase evolution and TLAG non-equilibrium growth mechanism

# Enabling *in-situ* XRD characterization of TLAG at ALBA





- Rayonix 2D (GI)WAXS CCD detector (1920 x 5760 pixels)
- Pixel size: 44.27 x 44.27  $\mu\text{m}$
- Tunable Sample  $\leftrightarrow$  Detector distance (<300 mm)
- Down to 100 ms per XRD frame

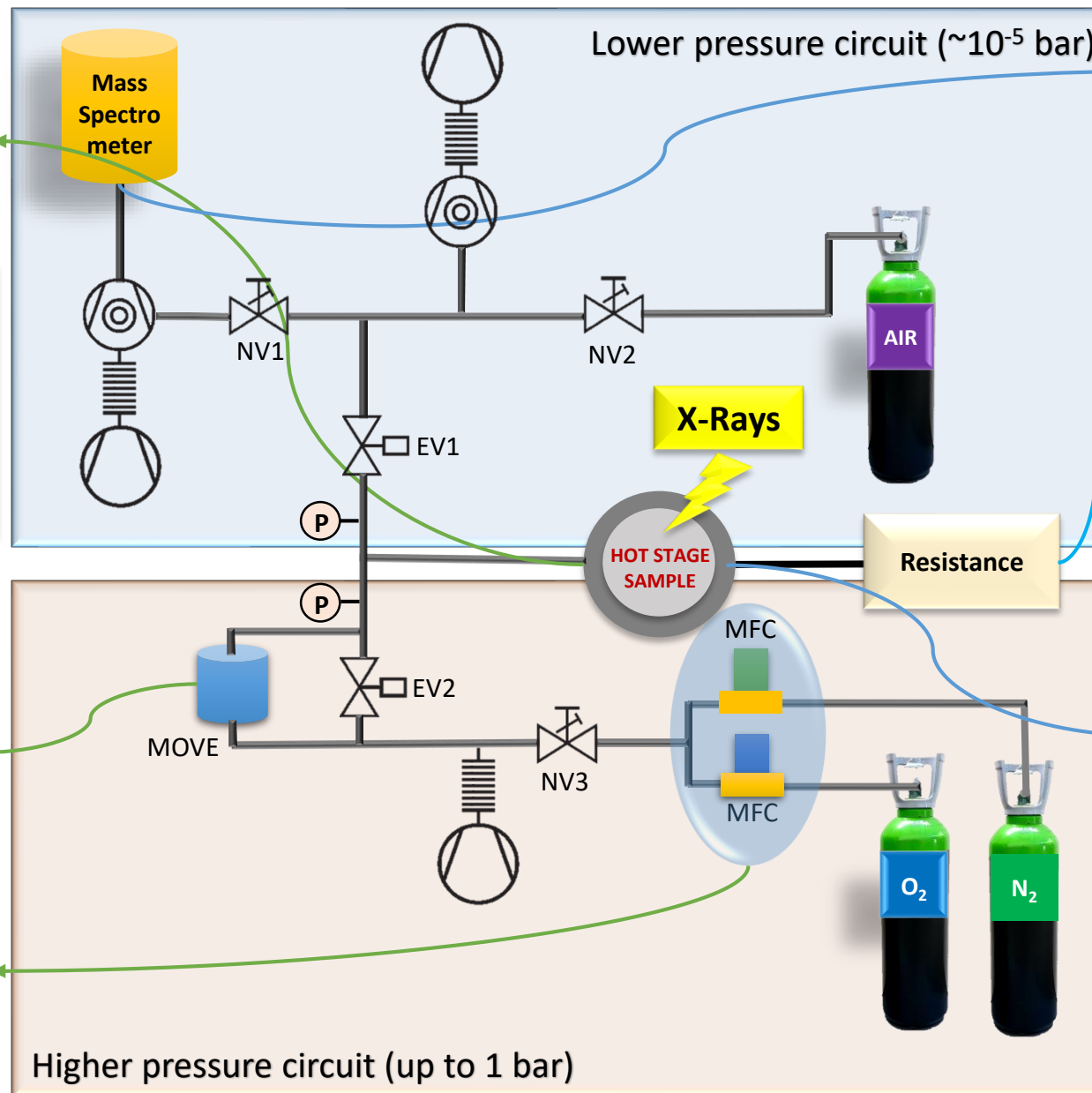
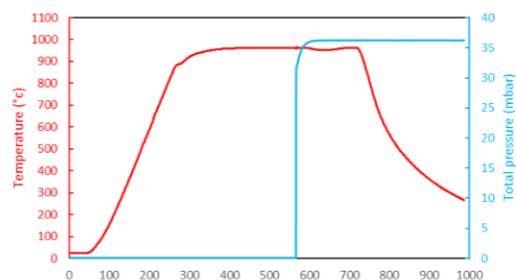
G of up to 2000 nm/s\*

\*t =400 nm

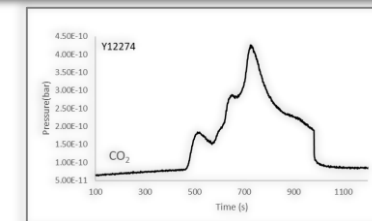
| 18 keV                   | YBCO (005) | YBCO (103) | BaCuO <sub>2</sub>    | BaCO <sub>3</sub> | Y <sub>2</sub> O <sub>3</sub> | CuO        |
|--------------------------|------------|------------|-----------------------|-------------------|-------------------------------|------------|
| 2 $\theta$ positions [°] | 16,99      | 14,50      | 12,97/12,6<br>1/13,32 | 10,6/<br>11,9     | 12,9                          | 15,7/17,08 |

# In-situ TLAG-XRD-R-MS

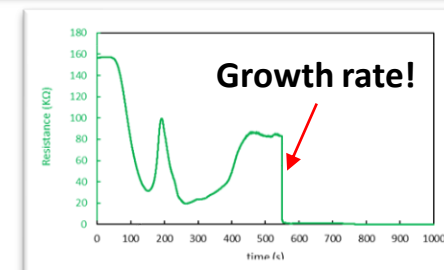
- ✓ Temperature of the reaction (up to 1000° C)
- ✓ Heating rate (up to 300° C/min)
- ✓ T change at the pressure jump (calibration of the PID)



- ✓ Volatile products of reaction: BaCO<sub>3</sub> decomposition



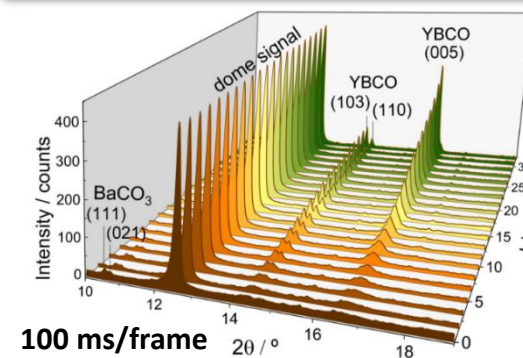
- ✓ Resistance of the film (insulator to metallic transition)



- ✓ Velocity of the pressure jump (0.4 s - minutes)

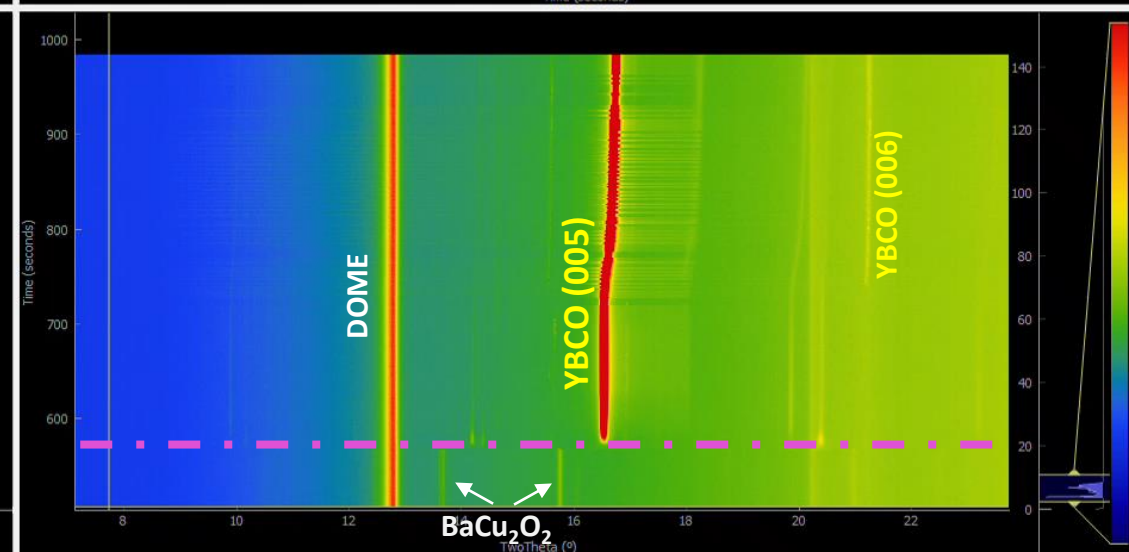
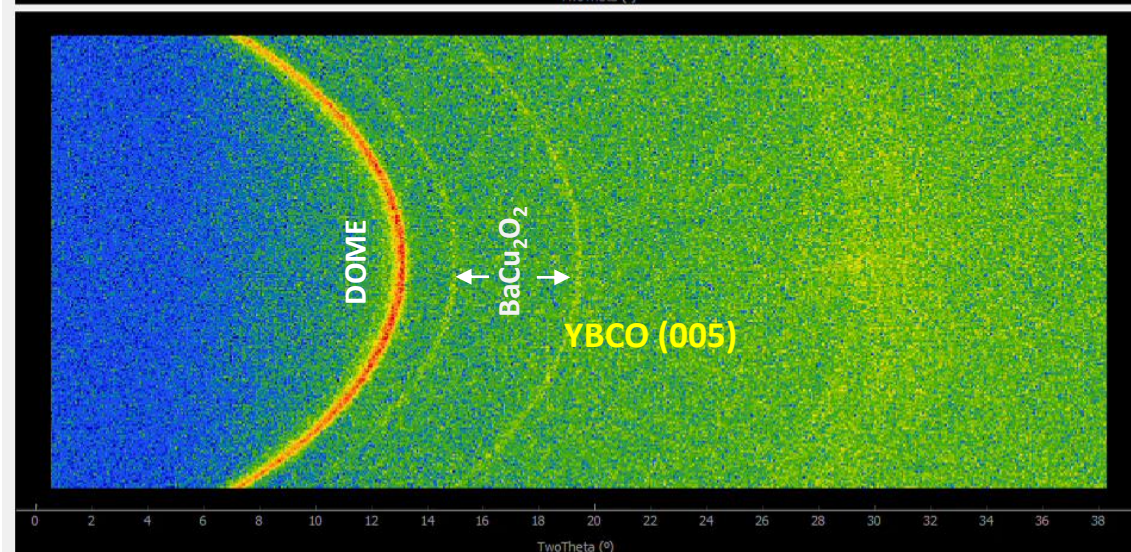
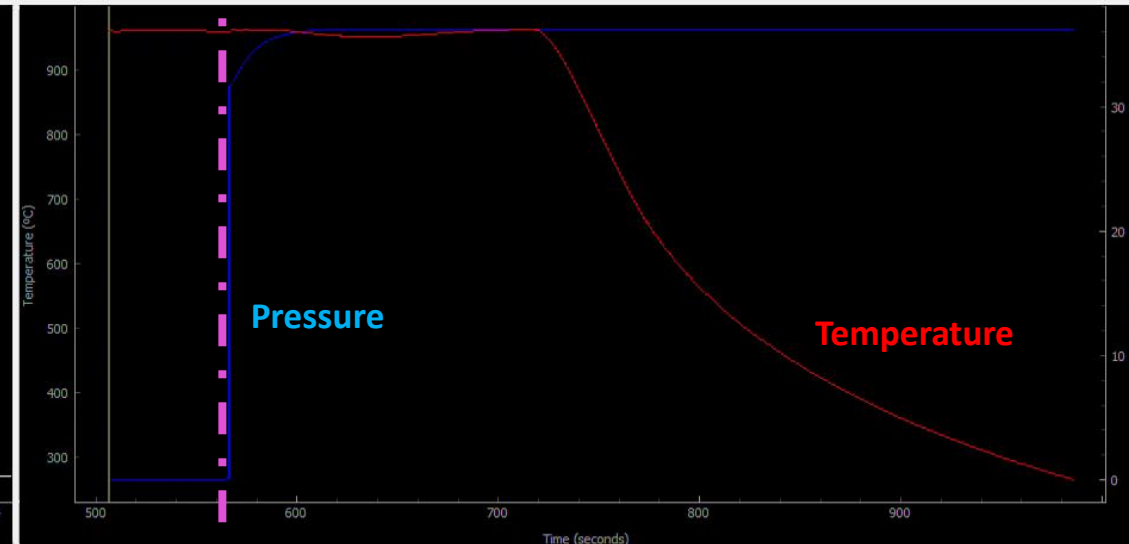
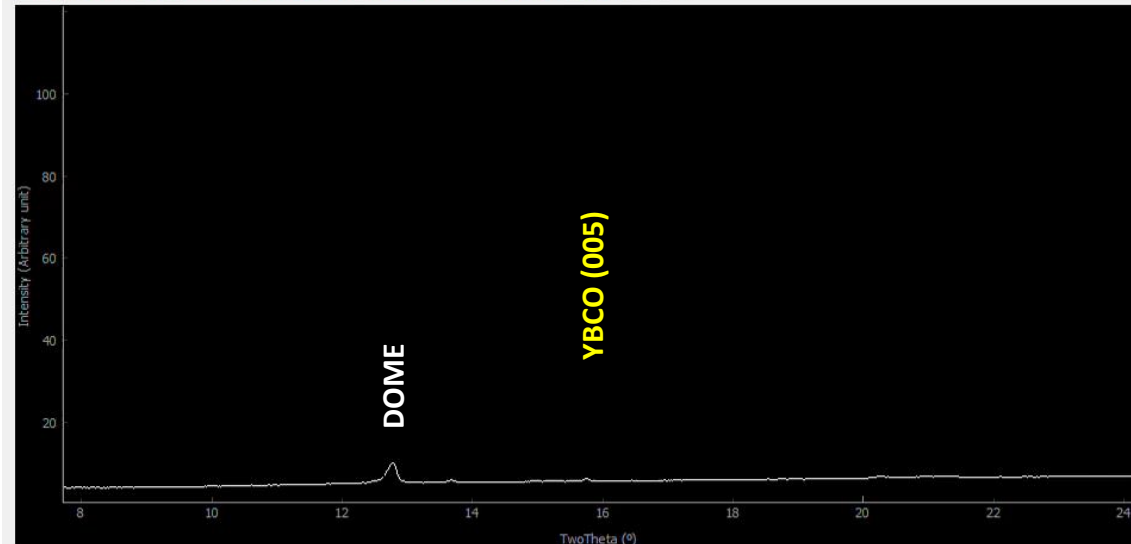
- ✓ Total pressure (up to 1 bar)
- ✓ Oxygen partial pressure (1 - 15 mbar)
- ✓ Flow rate (300 - 1000 ml/min)

- ✓ X-Ray Diffraction



Temperature=961.12 °C, Pressure=0.0496 mbar Time=507.0 seconds Index=5

log\_Y12050\_003.log, Y12050\_003



Load log file

Load integrated images

Load diffraction images

Load fitting

None

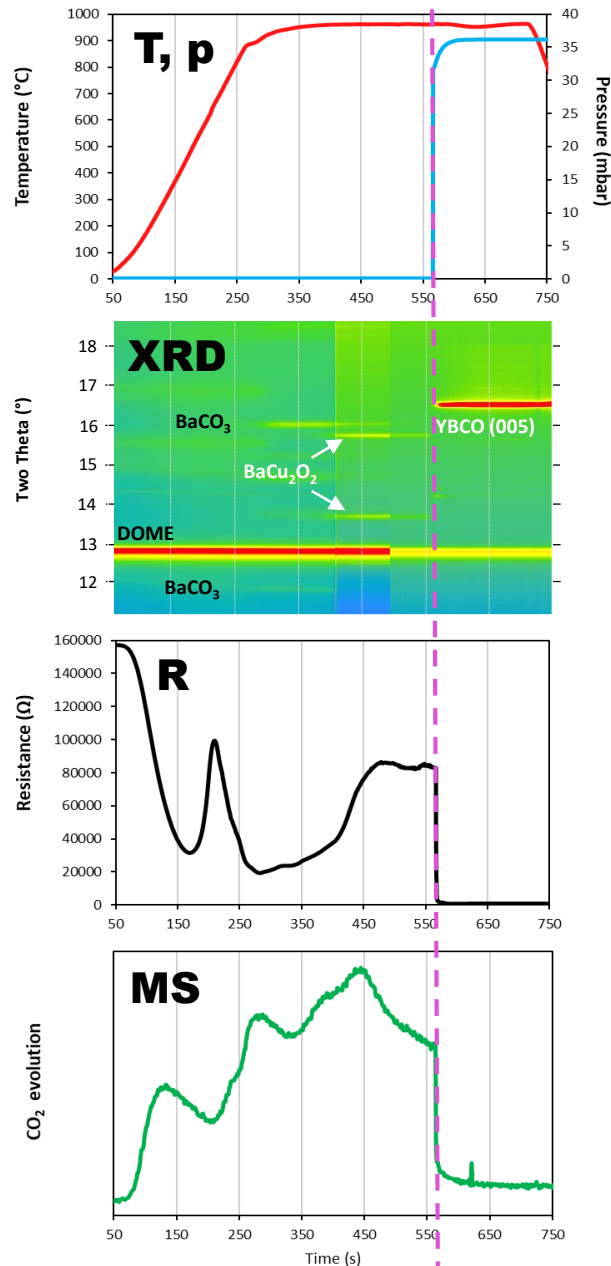
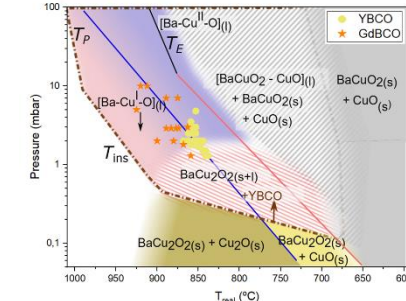
☒ Apply baseline to trend plot

TLAG visualizer developed by Jordi Aguilar  
(now part of the ALBA Controls)

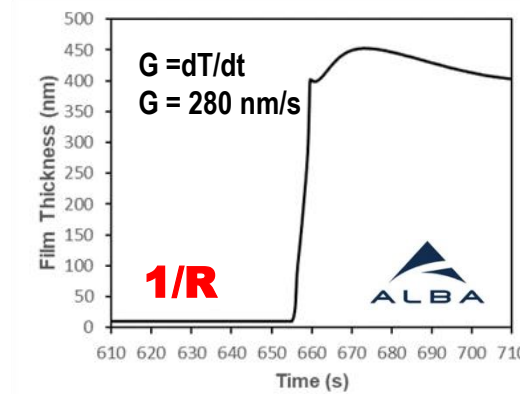
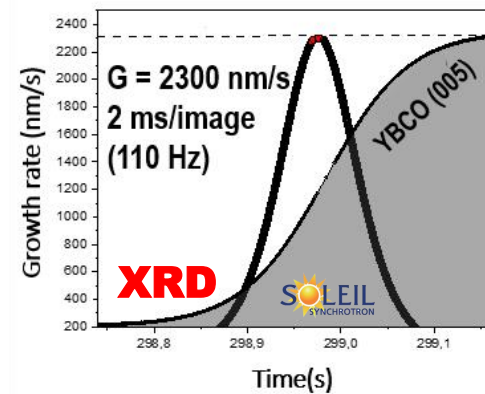
# In-situ TLAG-XRD-R-MS

## ✓ Time-correlated data

For every XRD point: T, p, R and MS are collected



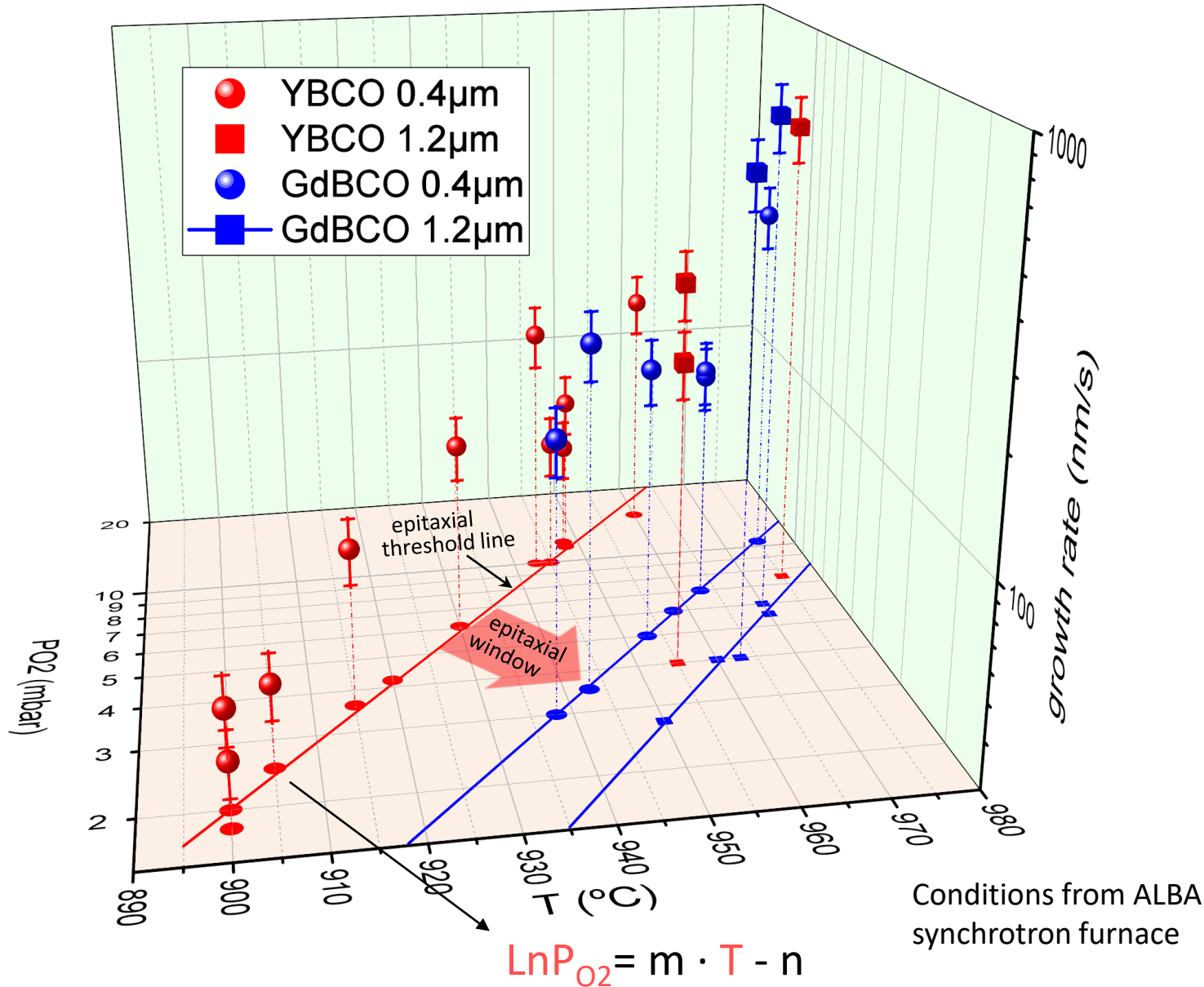
## ✓ Growth rate calculation: two methods



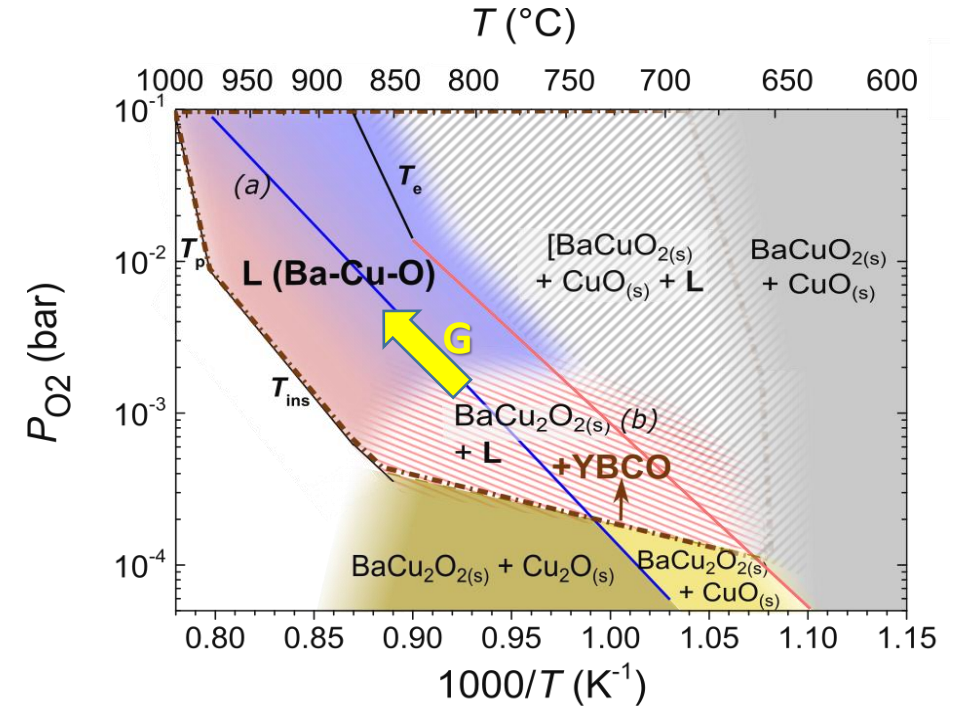
## ✓ The BaCO<sub>3</sub> decomposition: crucial step



# Growth rate dependence on TLAG growth conditions



Growth rate,  $G$ ,  $\uparrow$  if  $P_{O_2}$  (and  $T$ )  $\uparrow$



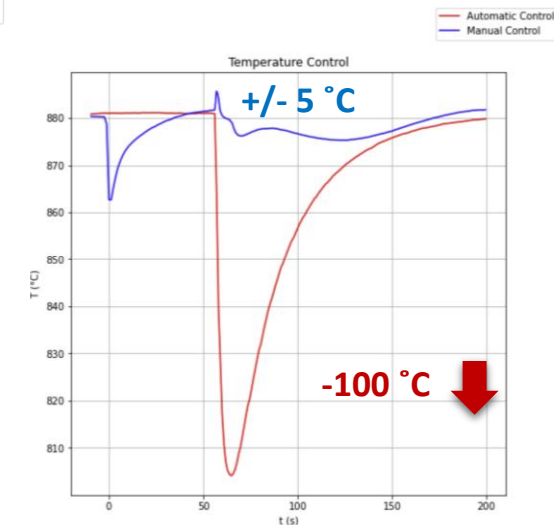
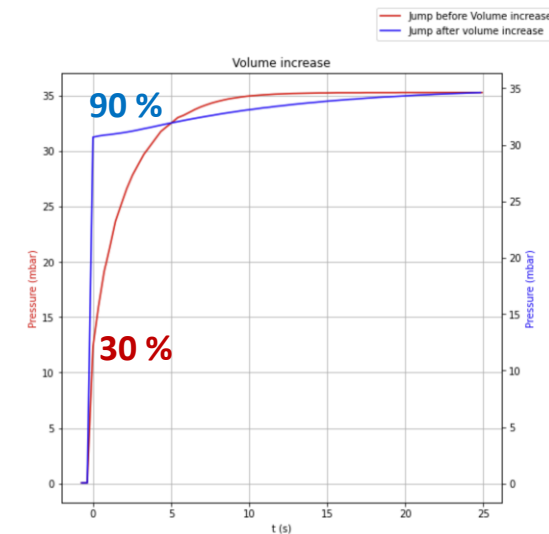
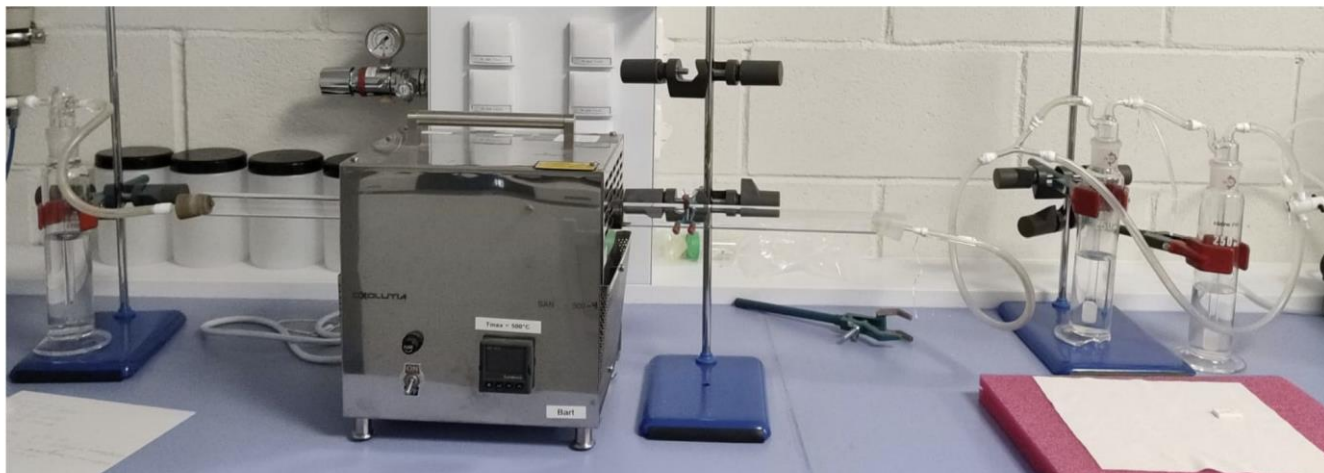
# Sample preparation and test laboratory at ALBA (Battery Lab)



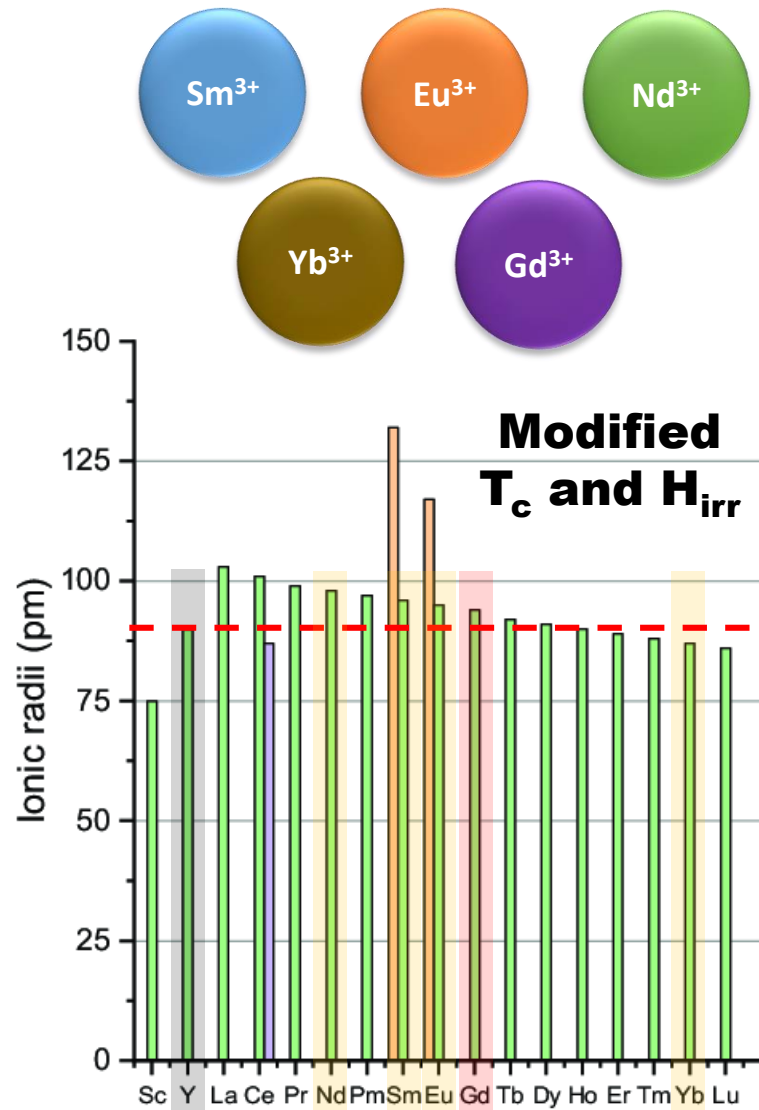
## Deposition, pyrolysis and growth



## Pre-beamtime calibrations and tests

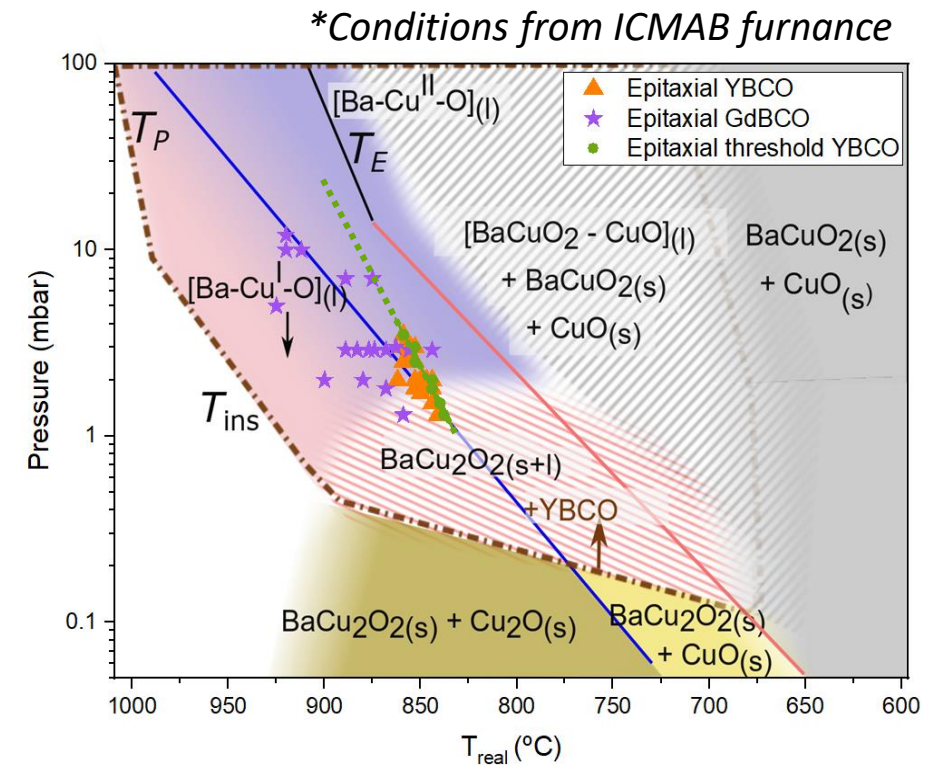


# Effect of the Rare Earth on TLAG



In TLAG the RE modifies:

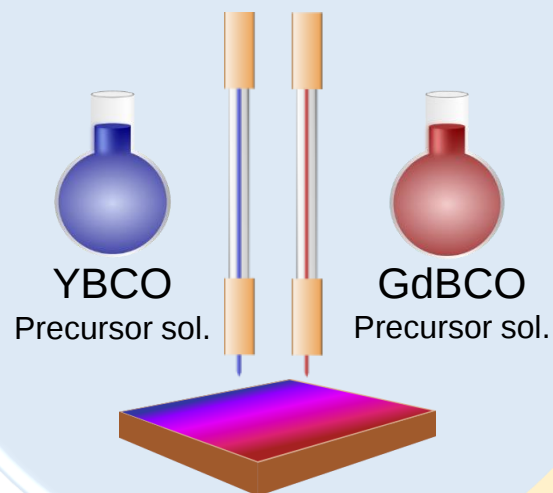
- Epitaxial windows
- Supersaturation value
- Solubility in the liquid
- Nucleation density
- Growth rate



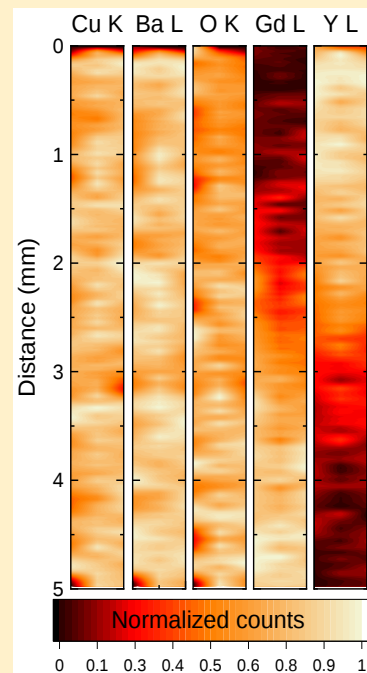
**Wide range of conditions of  $p_{O_2}$  and temperature has been demonstrated for the c-axis YBCO and GdBCO TLAG growth**

# Fast screening approach with mixed REBCO

## Combinatorial Ink Jet Printing



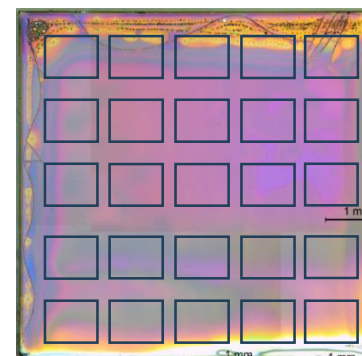
## EDX analysis



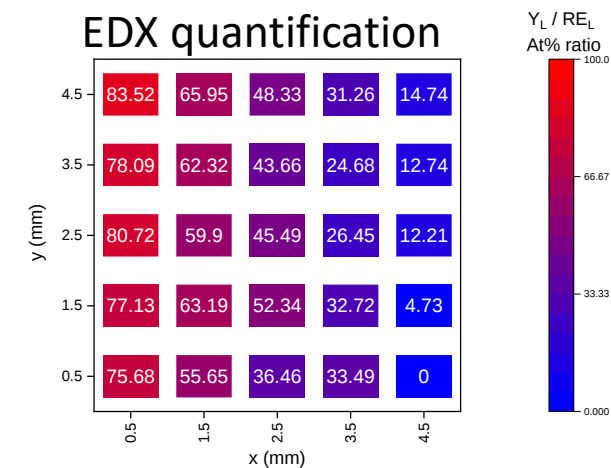
YBCO

GdBCO

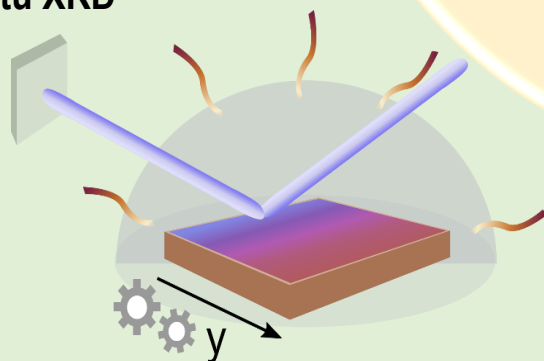
## Optical Image



## EDX quantification



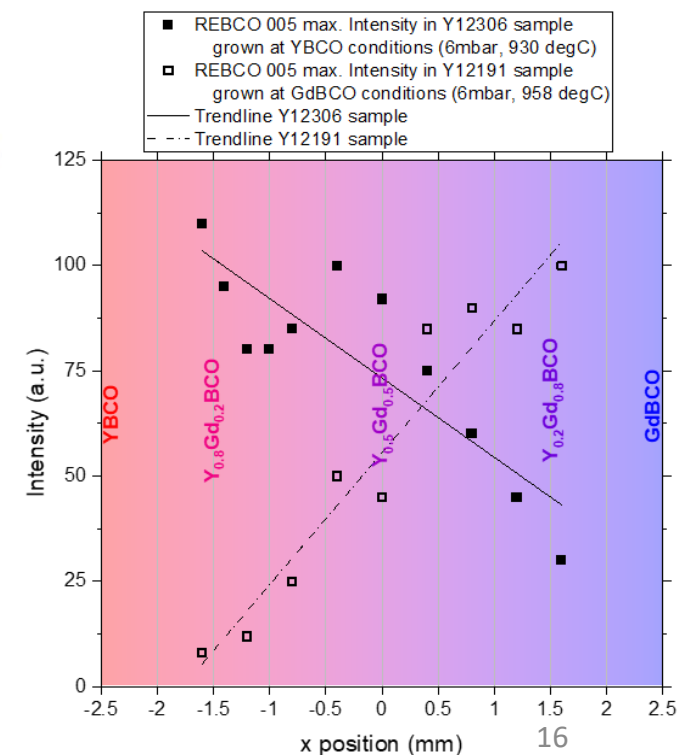
## In-situ XRD



Data segmented by positions for analysis

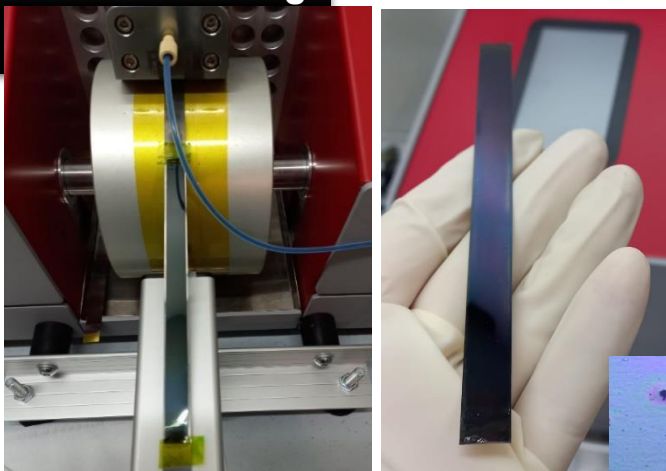


Fast screening across varying compositions



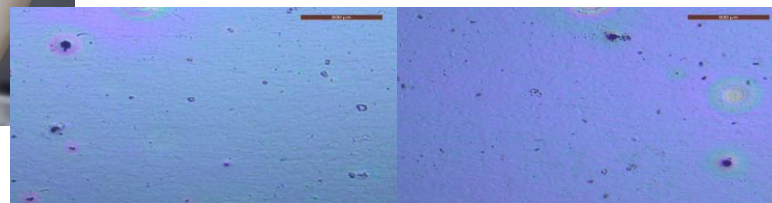
# Towards industrialization of TLAG

## Slot-die coating



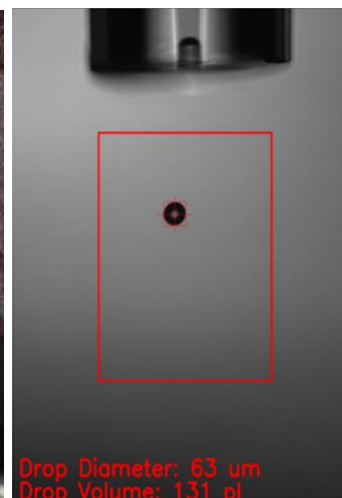
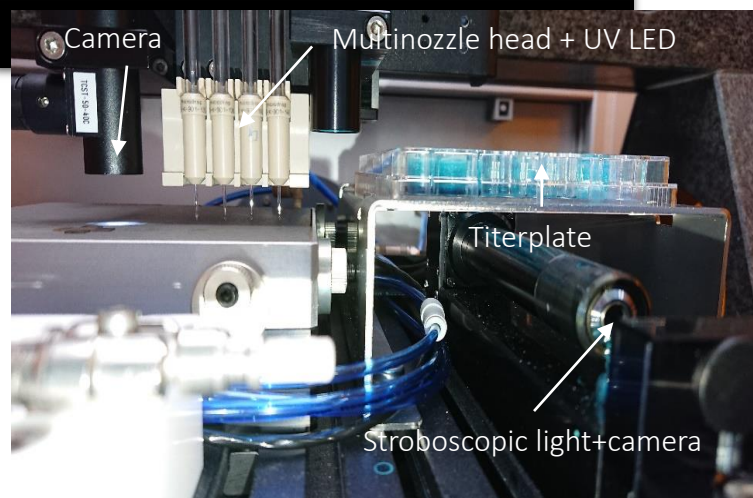
15 cm, pyrolyzed film (6 layers, ~3  $\mu\text{m}$ )

Homogeneous depositions and pyrolysis are reached



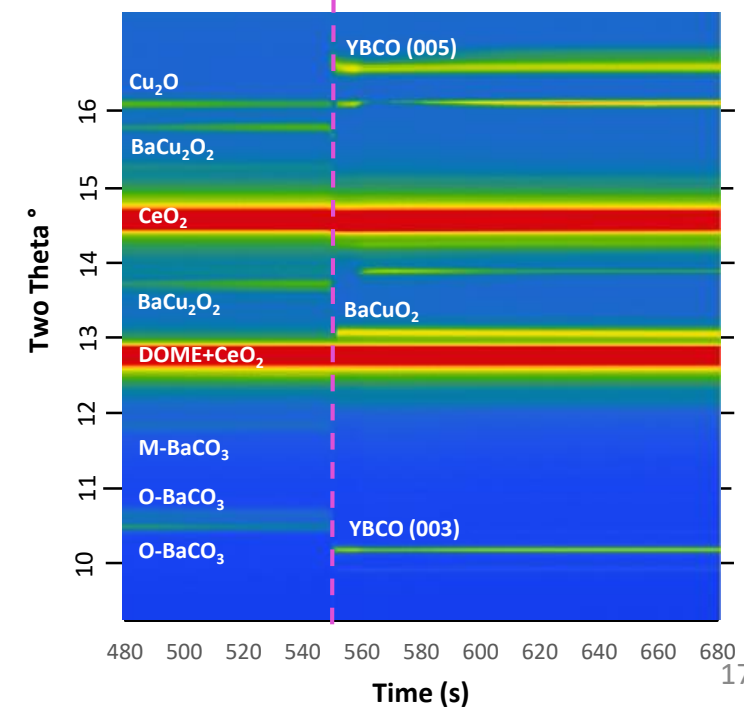
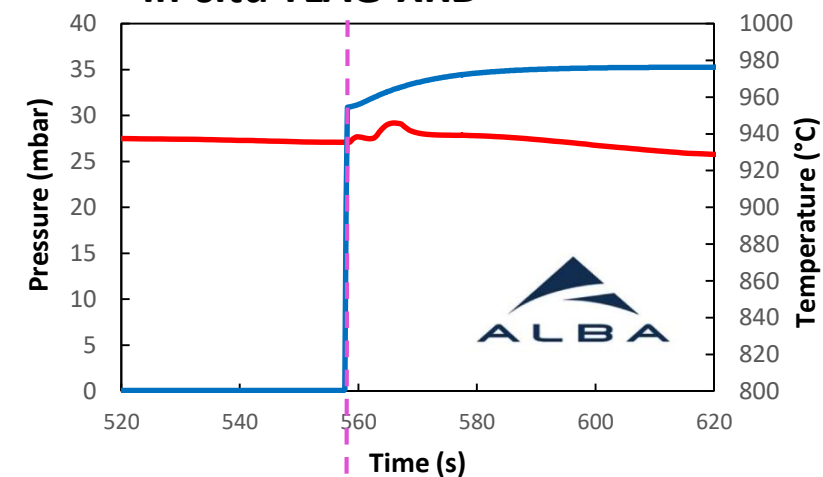
Piece of 6.5 cm pyrolyzed tape with 6 layers

## Ink Jet Printing deposition



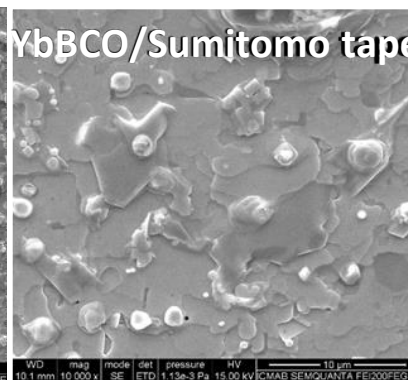
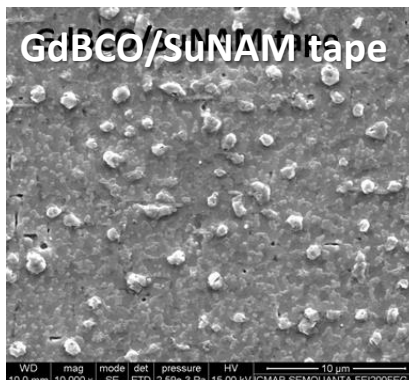
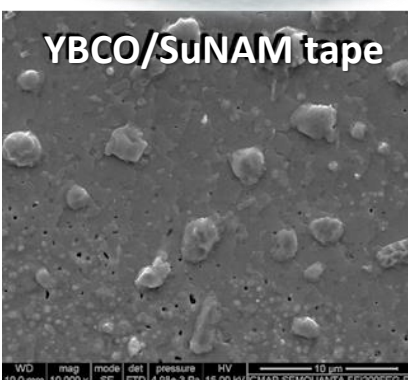
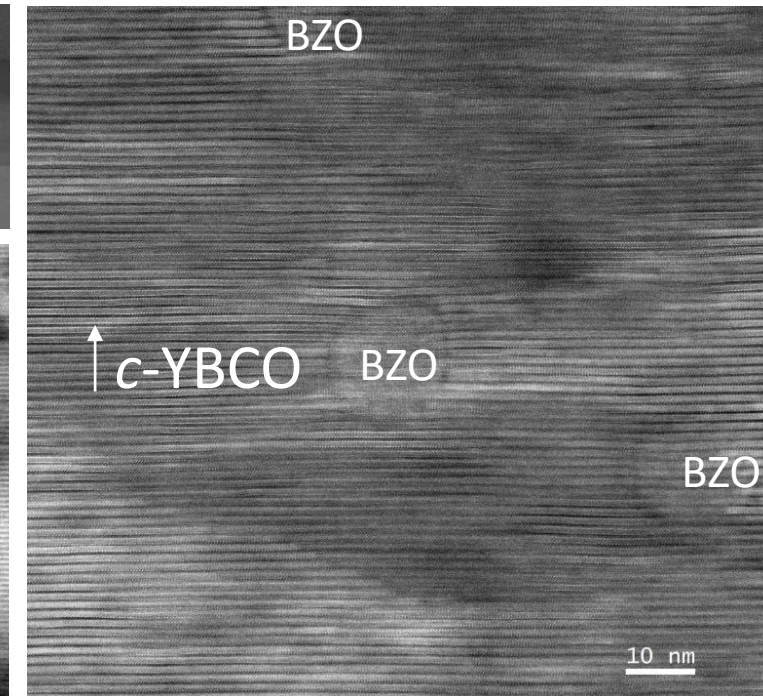
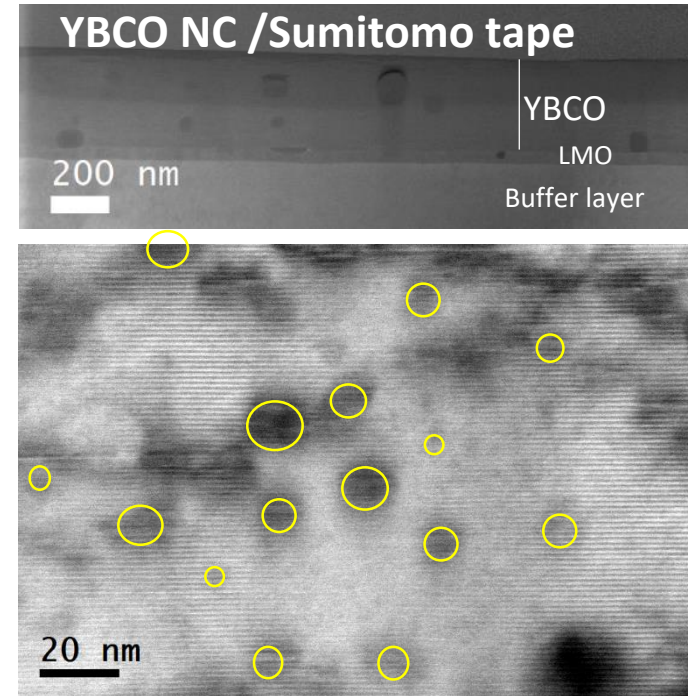
1.7  $\mu\text{m}$  pyrolyzed film (1 layer)

## In-situ TLAG-XRD



# TLAG Coated conductors

Slot die  
now with 40 mm-width  
printhead capabilities

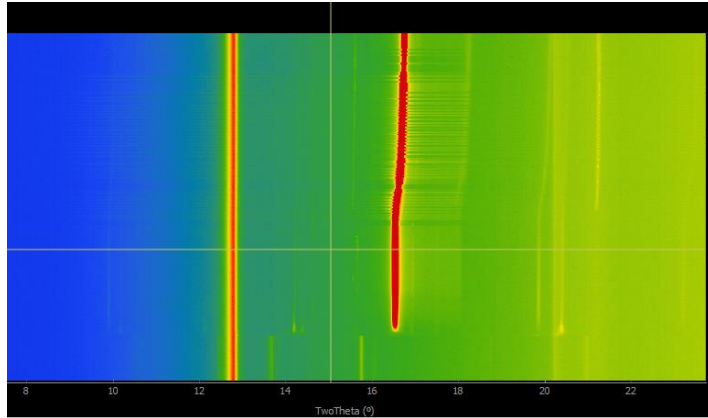


Microstructure is reproduced in 250-750 nm CC  
High superconducting properties:  $J_c(77K) = 1.7-2 \text{ MA/cm}^2$

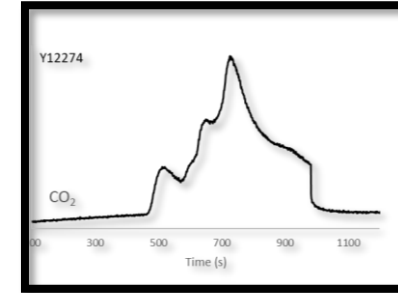
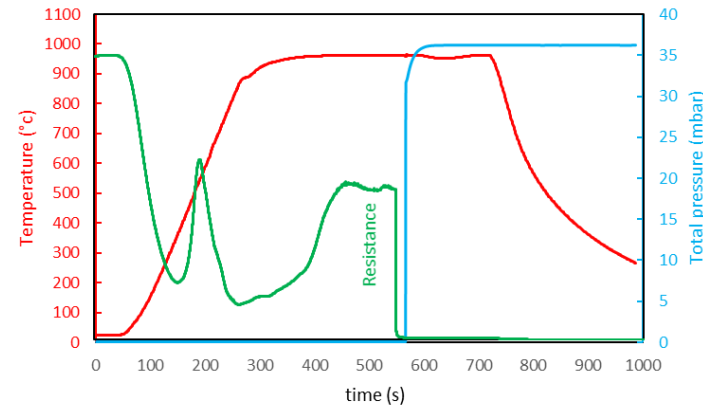
**FUTURE**

# Correlative characterization

## In-situ TLAG-X-RAY DIFFRACTION



NCD-SWEET beamline

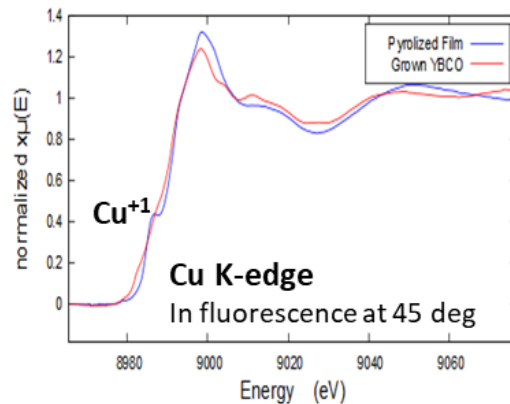


- ✓ Crystalline phases
- Precursors
- Intermediates
- grown REBCO
- ✓ BaCO<sub>3</sub>
- Structure
- Decomposition
- ✓ Growth rate (XRD, R)
- ✓ No liquid information!

## In-situ TLAG-X-RAY ABSORPTION

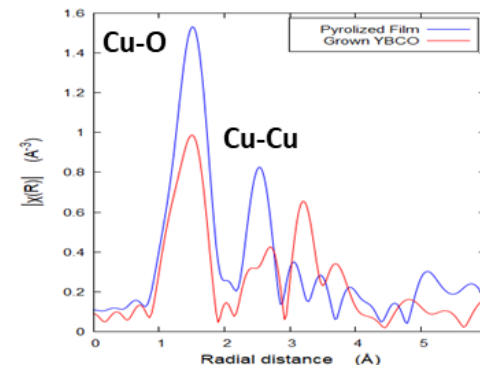
**XANES**

*local electronic structure*



**EXAFS**

*first-order atomic pair correlation*



**CLAESS  
beamline**

- ✓ Amorphous **Transient Liquid**
- Cu valence state
- ✓ Different liquid composition
- effect on the Cu valence

# Summary

## *In-situ* X-Ray Diffraction:

- Essential to reveal the mechanisms of the TLAG growth of REBCO films
- Build non-equilibrium kinetic phase diagrams
- Correlation between precursors, intermediates, and final films with T, p, mass spectrometry and resistance

## **TLAG :**

- non-equilibrium process kinetically controlled by supersaturation of the rare earth in the liquid
- ultrafast growth rates
- high performance films
- relatively low cost to performance ratio method
- may revolutionize the industrial applications of REBCO

# Acknowledgements



Eduardo Solano  
Marc Malfois



**NCD-SWEET**

Laura Simonelli

-

**CLAESS**

ALBA Safety Department



Cristian Mocuta – DiffAbs



Carla Torres, Emma Ghiara, Ona Mola – current PhDs

Jordi Aguilar – currently at ALBA Controls Department

Daniel Sanchez, Jordi Farjas - University of Girona

Victor Fuentes – Technician at the Battery Lab, ALBA